

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Luo et al.

Serial No.: 10/826,985

Filed: April 19, 2004

For: METHODS FOR FORMING PROTECTIVE
LAYERS ON SEMICONDUCTOR DEVICE
COMPONENTS SO AS TO REDUCE OR
ELIMINATE THE OCCURENCE OF
DELAMINATION THEREOF AND CRACKING
THEREIN

Confirmation No.: 3493

Examiner: J. Stark

Group Art Unit: 2823

Attorney Docket No.: 2269-5565.1US
(2002-1124.01/US)

VIA ELECTRONIC FILING
March 28, 2008

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Examiner:

This Response follows the final Office Action of January 28, 2008, the shortened statutory period for response to which expires on April 28, 2008. This response is being submitted within two months of the mailing date of the final Office Action.